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## -PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
••	:	Examiner: D. Dong
ICHIRO NOMURA ET AL.	)	
	:	Group Art Unit: 2875
Application No.: 09/809,055	)	
	:	
Filed: March 16, 2001	)	
	:	
For: METHOD AND APPARATUS FOR	)	
MANUFACTURING IMAGE	:	
DISPLAYING APPARATUS	)	January 13, 2004

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## SECOND INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. A copy of the listed document

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

January 13, 2004
(Date of Deposit)

Frank A. DeLucia, Jr.
(Name Frattorney for Applicant)

January 13, 2004

Signature

Date of Signature

is also enclosed, together with a copy of an October 13, 2003 Korean Official Letter and its Japanese translation, each citing the document.

The concise explanation of relevance for the non-English document is provided by the English-language abstract attached thereto.

Document 11-135018, cited in the Korean Official Letter, already is of record in the present application, and therefore is not cited again herein.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

The U. S. Patent and Trademark Office is authorized to charge any fee that maybe required in connection with this Information Disclosure Statement to Deposit Account 06-1205.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

Registration No. 42,476

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New York, New York 10112-3800
Facsimile: (212) 218-2200

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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE										
LIST OF REFERENCES CITED BY APPLICANT(S)  APPLICANT  Ichiro Nomura et al.										
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<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.